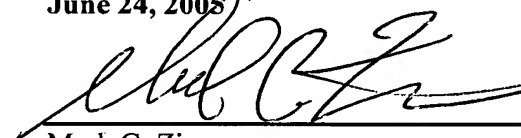




IFW

PATENT  
Docket No. 20063/OG03-046

**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant(s): ) I hereby certify that this paper and the  
 ) documents referred to as enclosed  
**In Su KIM** ) therewith are being deposited with the  
 ) United States Postal Service as first  
U.S. Serial No.: 10/758,188 ) class mail, postage prepaid, in an  
 ) envelope addressed to Commissioner  
For: "Methods of Fabricating ) for Patents, P.O. Box 1450,  
Semiconductor Devices" ) Alexandria, Virginia 22313-1450 on  
 ) this date:  
Filed: 1/15/2004 )  
 ) **June 24, 2005**  
Group Art Unit: 2811 )  
 )  
Examiner: Not Yet Assigned )  
 )  
 )   
 ) Mark C. Zimmerman  
 ) Attorney for Applicant(s)  
 ) Registration No. 44,006

**STATUS LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

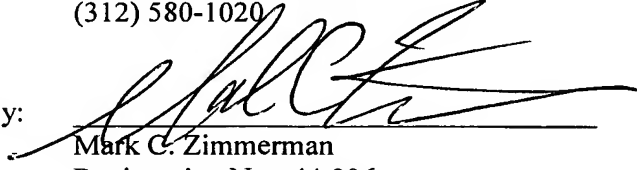
Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC  
USPTO Customer Number 34431  
20 North Wacker Drive  
Suite 4220  
Chicago, Illinois 60606  
(312) 580-1020

June 24, 2005

By:

  
Mark C. Zimmerman  
Registration No.: 44,006